

_	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/576,494	HATTORI ET AL.	
	Examiner	Art Unit	
	John S. Chu	1795	

SEARCHED				
Class	Subclass	Date	Examiner	
430	191	12/2117)e-	
430	192	,		
430	193			
430	18			
430	326			
430	330			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
·	DATE	EXMR		
EAST SEARCH UPDATED	12 (2007	Jse		